



An Alternative to Helium Leak Checking

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Introduction

- Motivation for an alternative to helium leak checking
- Remote plasma emission monitoring (RPEM)
- RPEM for leak checking
- Detection gas
- Ar leak detection
- Other uses
- Conclusions





- "Helium Shortage 4.0"
 - Lack of supply driven by political pressures and production problems
 - Difficult to procure Helium even with long running gas contracts unless in key industries
- Finite resource
 - Once released into atmosphere lost forever
 - Use should be prioritised for critical applications
- Technological
 - Mass spectrometer based mobile leak checkers
 - Costly to produce
 - Expensive to maintain
 - Detection limit down to 1E-12 mbar l/s often unnecessary
- Large component testing (e.g. fuel tanks) where minimising use of helium is advantageous typically in accumulation testing





Existing techniques

He vacuum												
Ar RPEM vacuum												
He sniffing												
Hydrogen (5%) sniffing												
He accumulation												
Hydrogen (5%) accumulation												
Pressure decay testing												
Leak rate mbar I/s	10 ⁰	10-1	10-2	10 ⁻³	10-4	10 ⁻⁵	10 ⁻⁶	10-7	10	8	10 ⁻⁹	10 ⁻¹⁰



Targeting helium-based technologies

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- Standalone / portable leak checker for helium vacuum initially
- Leak rates <1E-7 to 1E-3 mbar l/s
- Accumulation / sniffing applications





RPEM for He leak detection



- Possible to localise air leaks by monitoring He emission
- Not a complete replacement for a dedicated He leak detector
- Leak rates are not directly quantifiable

Why not use helium?

- He low light emitter
- Easily supressed by larger molecules



10

9

Detection gas

CO2:

- Low presence in atmosphere (~0.04%)
- Complex interactions in plasma
- Organic species dissociating in plasma could make calibration challenging



CO2 Leak

Difference

Wavelength (nm)



Detection gas

8



Argon:

- Higher presence in atmosphere (~1%)
- Inert
- Defined peak at 750nm



Vacuum Setup



- Conventional leak checkers rely on back-streaming
- Opportunity for a lower cost / more robust unit based on RPEM technology

RPEM leak checker pumping differences?

- Can start measuring directly at higher pressures
- Reduced sensitivity below certain pressure; reduce pumping if vacuum <~1E-4 mbar, opposite to He LC which have greater sensitivity at higher vacuum







Vacuum Setup

- Sensor pressure critical in determining signal level
- Optimum pressure for signal strength; requires crossover to low conductance pumping
- Required parameters:
 - Low conductance path orifice size
 - Pressure to switch to low conductance mode







Ar Leak Detection

Fixed leak at 3.8E-6 mbar l/s 1000ms integration, 1 scan, 50uA emission Integrate 745-755nm



Pressure response:

- Sensor pressure increased by throttling TMP
- Increase in signal strength by 50% by working at optimum pressure
- Signal falls off when Argon background increases with high throttling



Ar Leak Detection



Pulsed leak response:

- 2E-7 mbar l/s detectable without throttling
- Response time < 5secs
- Opportunity to improve detection signal strength

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Ar Leak Detection



- Required Calibration curves:
 - Pressure vs signal (at fixed leaks / pulse length / current)
 - Signal vs leak (at fixed pressures / pulse length / current)
 - Steady state (i.e. long pulse) signal vs leak
 - Understanding to date:
 - Calibration will require pressure correction
 - Good fit to pressure in range tested
 - Assume operation at fixed current
- He equivalent Ar leak rate will be a function of integration time (I), signal (S), pressure (P) and potentially partial pressure (PP)

LR(He equivalent mbar l/s) = fn(I,S,P,PP?)



Other uses for RPEM

Vacuum process control / quality monitoring



















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15



AI based leak detection



- Uses partial pressure data from RPEM spectrum
- Could be incorporated into RPEM leak checker advantage of a technique that detects more than a single species
- Chamber determined leak-tight in less than 10 minutes pumping time
- Leak checking algorithm successful below 3E-2
 mbar

16



Conclusions

- RPEM used to detect He equivalent leaks down to low E-7 mbar l/s
- Heavier gas leak detection requires different pumping arrangement to regular mass spec based systems
- Higher pressure of RPEM works well in such systems
- Calibration more complex but possible by linking pressure and water vapour data
- Offers additional spectral data compared to single species mass spectrometry





Project No. 10055251



Innovate Leak detection by remote plasma optical emission spectroscopy

- Thank you for your attention
- Please visit us at the exhibition Booth 704